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Confirmation No. 6828

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	PAWLAK, <i>et al.</i>	Examiner:	Nhu, D.
Serial No.:	10/596,450	Group Art Unit:	2818
Filed:	June 14, 2006	Docket No.:	NL031496US1
Title:	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE OBTAINED WITH SUCH A METHOD		

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FINAL OFFICE ACTION AMENDMENT AND RESPONSE

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No. <b>65913</b>
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Dear Sir:

In response to the Office Action dated October 23, 2007, please reconsider the application in view of the following amendments and remarks.

Amendments to the specification begin on page 2 of this paper, and a complete listing of the claims, to include any amendments presented therein, begins on page 3 of this paper.

Remarks/Arguments follow on page 5.

**Authorization is provided to charge/credit Deposit Account 50-0996 (NXPS.335PA) any requisite fees/overages to enter this paper.**